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10595434 - GALL: 1712

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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> ( Not for submission under 37 CFR 1.99)	Application Number		10595434	
	Filing Date		2006-04-19	
	First Named Inventor	Karg et al.		
	Art Unit			
	Examiner Name			
	Attorney Docket Number		CH920030009US1	

U.S.PATENTS						
Examiner Initial*	Cite No	Patent Number	Kind Code <sup>1</sup>	Issue Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear
	1	4550257		1985-10-29	Binnig et al.	
	2	5294465		1994-03-15	Gallagher	

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Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>5</sup>
	1	Search report 10/595,434 for PCT/IB2004/003696 completed Jan 27th, 2005	<input type="checkbox"/>
	2	YAU S T et al: "Laser-Assisted Deposition of Nanometer Structures using a scanning tunneling microscope." Applied Physics Letter, American Institute of Physics, New York, US, vol. 57, no. 27, 31 December 1990 (1990-12-31), pages 2913-2915, XP00222958, ISSN: 0003-6951	<input type="checkbox"/>
	3	Shtokman M I: "Possibility of Laser Nanomodification of surfaces by means of a scanning tunneling microscope" OPTOELECTRON INSTRUM DATA PROCESS; OPTOELECTRON INSTRUM DATA PROCESS; OPTOELECTRONICS, INSTRUMENTATION AND DATA PROCESSING, 1989, NO. 3, 1989 PAGES 27-37, XP009043144, PAGE 27, PARAGRAPH 1, PAGES 28-29, PAGES 33-36	<input type="checkbox"/>
	4	BONEBERG J ET AL: "Mechanism of nanostructuring upon nanosecond laser irradiation of a STM tip" APPL PHYS A; APPLIED PHYSICS A: MATERIALS SCIENCE AND PROCESSING OCTOBER 1998, SPRINGER-VERLAG GMBH & COMPANY KG, BERLIN, GERMANY, VOL 67, NO 4 , OCTOBER 1998 (1998-10), PAGES 381-384, XP002315242, PAGES 381, RIGHT HAND COLUMN	<input type="checkbox"/>

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